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Patent Application
2771-357 DIV (7486)**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****In re United States Patent Application of:****Applicant:** VAN BUSKIRK et al.**Application No.:** 09/928,860**Date Filed:** August 13, 2001**Title:** SCALABLE LEAD ZIRCONIUM
TITANATE (PZT) THIN FILM
MATERIAL AND DEPOSITION
METHOD, AND FERROELECTRIC
MEMORY DEVICE STRUCTURES
COMPRISING SUCH THIN FILM
MATERIAL**Docket No.:** 2771-357 DIV**Examiner:** FULLER, Eric B.**Art Unit:** 1762**Confirm. No.:** 8391**Customer No.:****25559****FACSIMILE TRANSMISSION CERTIFICATE****ATTN: Examiner Eric B. FULLER****Fax No.: (703) 872-9306**

OFFICIAL

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Number of Pages (including cover)

Yongzhi Yang

August 12, 2004

Date

**RESPONSE TO MAY 28, 2004 OFFICE ACTION
IN UNITED STATES PATENT APPLICATION NO. 09/928,860**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir/Madam:

In response to the May 28, 2004 Final Office Action in the above-identified application, please amend the claims of the present application as set out in Section I (Amendments to Claims) hereof. Remarks concerning the Office Action are set out in Section II (Remarks) hereof.